

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.10757276
Filing Date January 14, 2004
Confirmation No. 4316
Inventor.....Beaman, Kevin L.
AssigneeMicron Technology, Inc.
Group Art Unit 2813
Examiner Smoot, Stephen W.
Attorney's Docket No. MI22-2475
Title:..... Method of Forming a Structure over a Semiconductor Substrate

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO/SB/08A-B

The attached Form PTO/SB/08 is submitted In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, and your attention is directed to the references listed on the attached Form PTO/SB/08. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 2/1/08

By: 
James D. Shaurette
39833